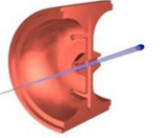




清華大學
Tsinghua University

ACCELERATOR LABORATORY
of TSINGHUA UNIVERSITY



VIGAS (Very Compact Inverse-Compton-Scattering Gamma-ray Source) project in Tsinghua University

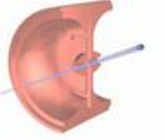
Jiaru Shi

on behalf of VIGAS team in Tsinghua University

The 2025 International Workshop on the High Energy Circular Electron Positron Collider



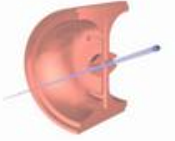
OUTLINE



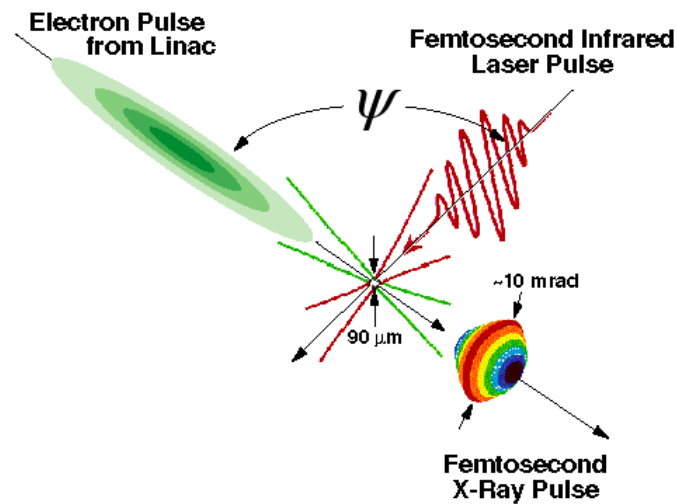
- Introduction
- Overview of the Beamline
- The S-band injector
- The X-band linac
- The laser System
- Progress and summary



Introduction

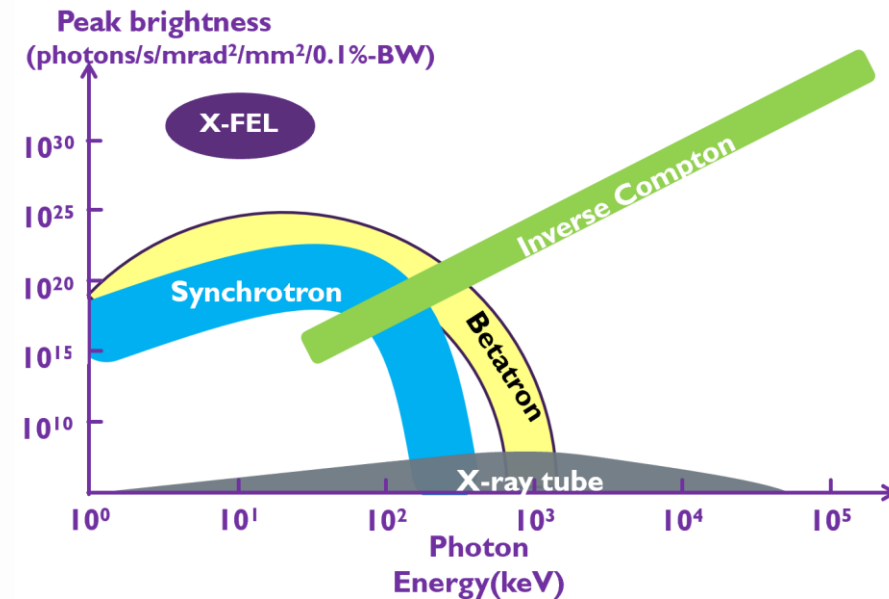


VIGAS: Very compact Inverse-compton-scattering Gamma-ray Source



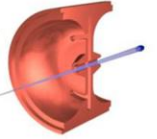
Characteristics

- Quasi-monochromatic
- Continuously adjustable Gamma-ray energy
- Small source size ~10μm
- Controllable polarization
- Ultra-short pulse length (fs~ps)



Advantages

- High peak brightness
- Gamma-ray
- Compact
- Affordable



ICS Studies at Tsinghua

2001

Beginning
of the TS
studies in
THU

2002

Collaboration
on TS with
CAEP

2006

Generation
of the 1st
scattered X-
ray signal at
TTX,
4.6 keV,
 1.7×10^5 ph/s

2009

Soft X-ray
generation
experiment
using
photocathode
rf gun at the
TTX,
290 eV, 1 ps,
 6.4×10^4 ph/s

2011

Generation
of the 1st
hard X-ray
pulse at
TTX,
51.7 keV,
 1.0×10^7 ph/s

2016

High-quality
X-ray
imaging
experiment,
20-50 keV,
 2.0×10^8 ph/s

2021

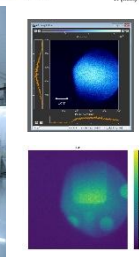
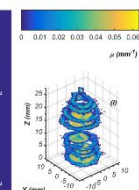
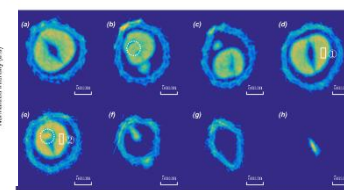
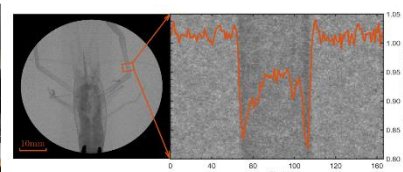
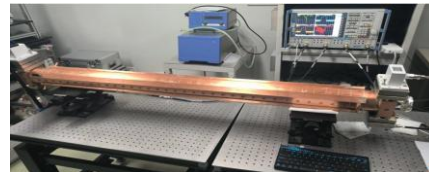
Beginning
of VIGAS
project

2024

VIGAS
installation
complete

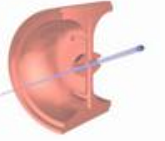
2025

Generation of
high-energy
X-rays in
VIGAS
collision
experiment





Introduction

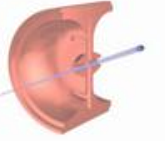


Goals of VIGAS project:

- Gamma-ray energy: **0.2~4.8 MeV** continuously adjustable
- Gamma-ray energy spectrum bandwidth(rms): **<1.5%** (w/ collimator)
- Photon production (photon/s):
 - **$>4 \times 10^8$ @0.2~2.4 MeV; $>1 \times 10^8$ @2.4~4.8 MeV**
- Photon production in 1.5% bandwidth (photon/s):
 - **$>4 \times 10^6$ @0.2~2.4 MeV; $>1 \times 10^6$ @2.4~4.8 MeV**
- Polarity: adjustable from **linear to circular**



Introduction



- Gamma-ray energy: **0.2~4.8 MeV** continuously adjustable
 - Collision angle between electron bunch and laser: **180 degree**

Laser energy:

- 800nm: 1.54 eV
- 400 nm: 3.08 eV

Electron energy:

- **Maximum > 320 MeV**
- **Minimum < 92 MeV**

$$E_{\gamma} = \frac{4\gamma^2}{1 + \frac{a_0^2}{2} + \gamma^2\theta^2} E_L$$

a_0 : Normalized vector potential

E_{γ} : Gamma energy

E_L : Laser energy

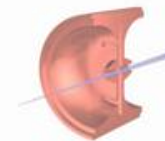
γ : Electron energy

θ : Observation angle

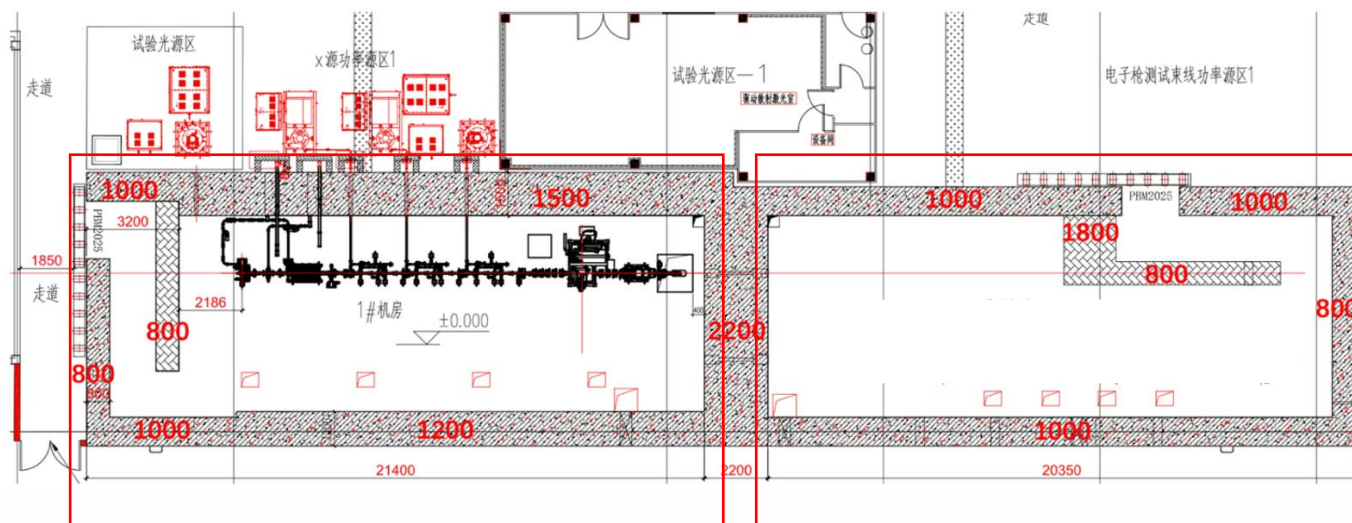
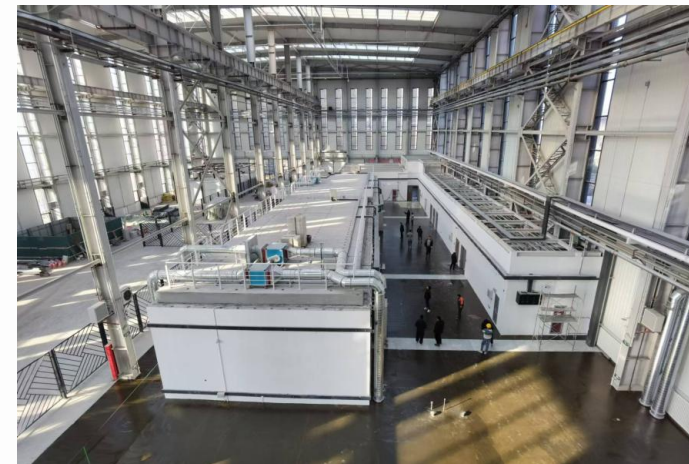
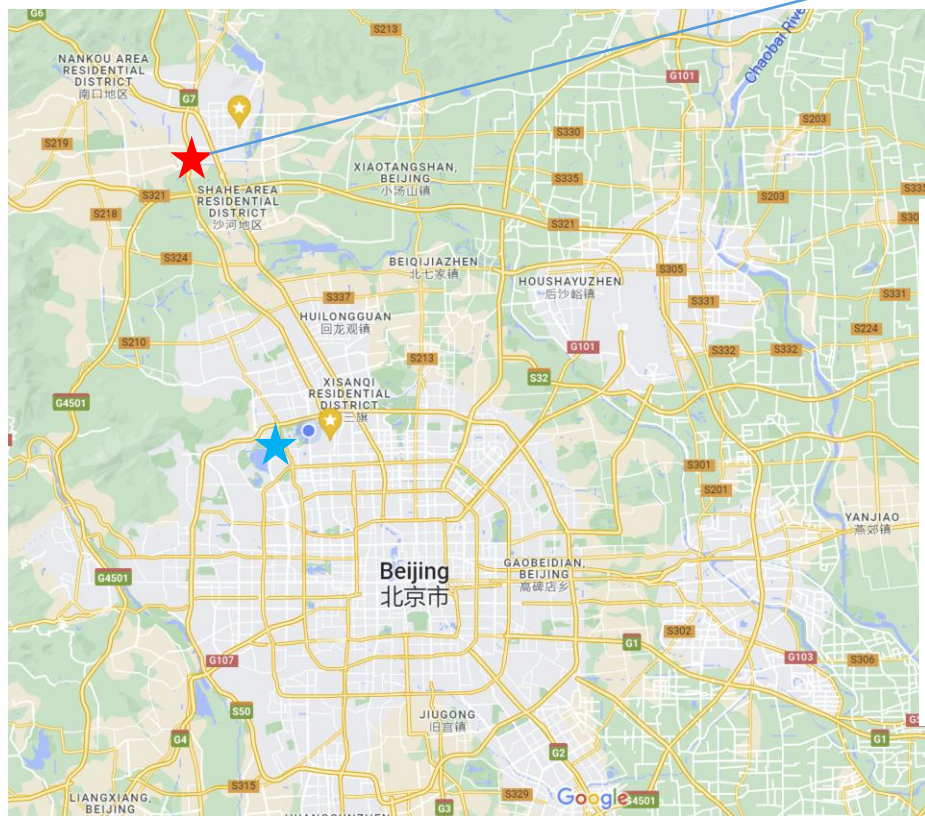
- 200 keV gamma-ray @800nm & 92 MeV electron
- 2.4 MeV gamma-ray @800nm & 320 MeV electron
- 4.8 MeV gamma-ray @400nm & 320 MeV electron



Footprint



Building area ~ 48,000m²
Bunker for VIGAS accelerator:
21 m × 10 m

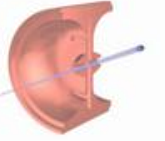


Accelerator section:
generating gamma ray

User section:
Gamma ray application



Overview of Accelerator System

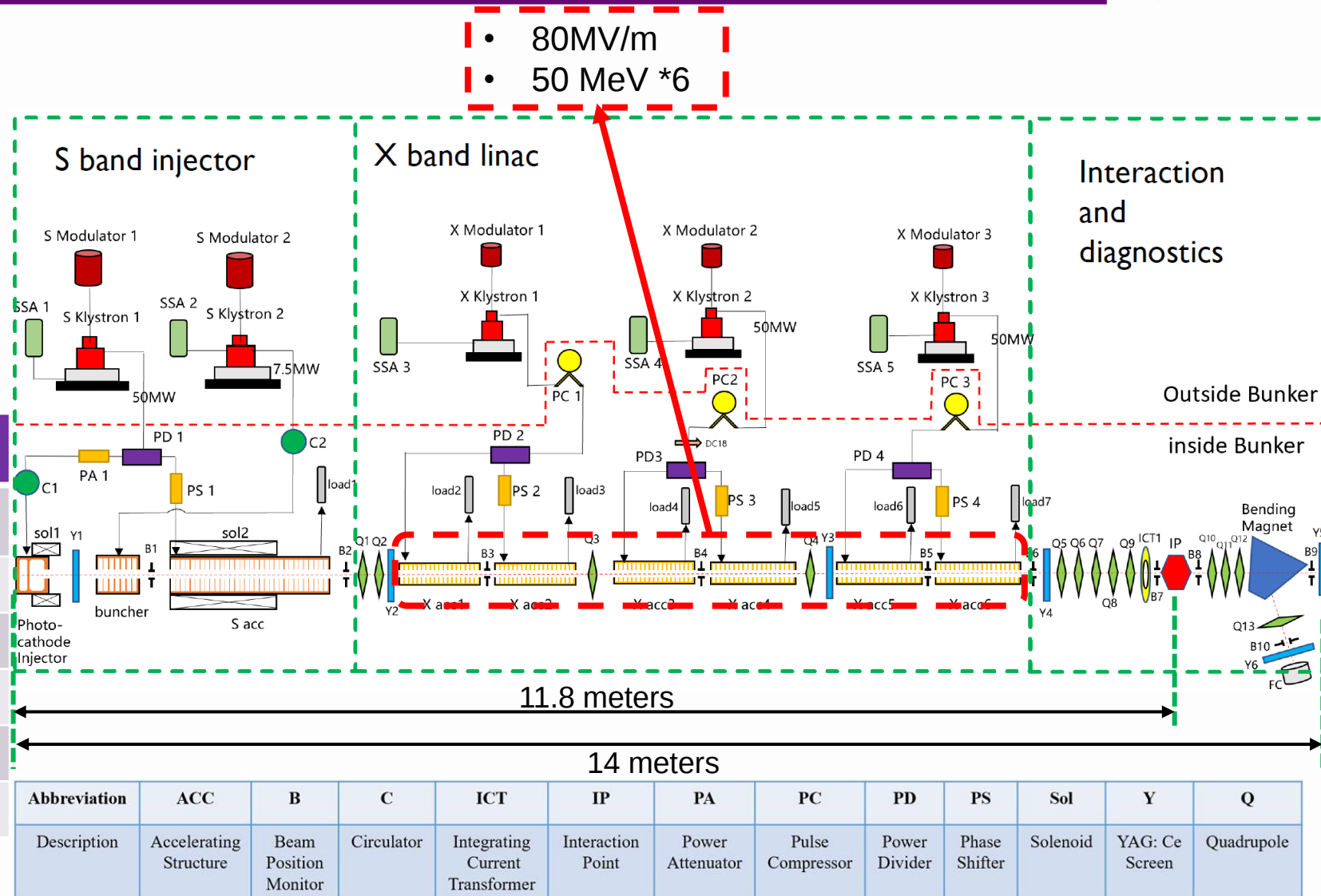


VIGAS Subsystems:

- **Accelerators subsystem**
- Laser subsystem
- Detection subsystem
- Control and synchronization subsystem
- Radiation protection subsystem

Properties	Value
Electron energy	50-350 MeV tunable
Charge	≥ 200 pC
Normalized emittance	< 0.6 mm mrad
RMS bunch length	< 2 ps
RMS energy spread	$< 0.3\%$
RMS beam size @IP	< 20 μm

Design parameters of
accelerator subsystem

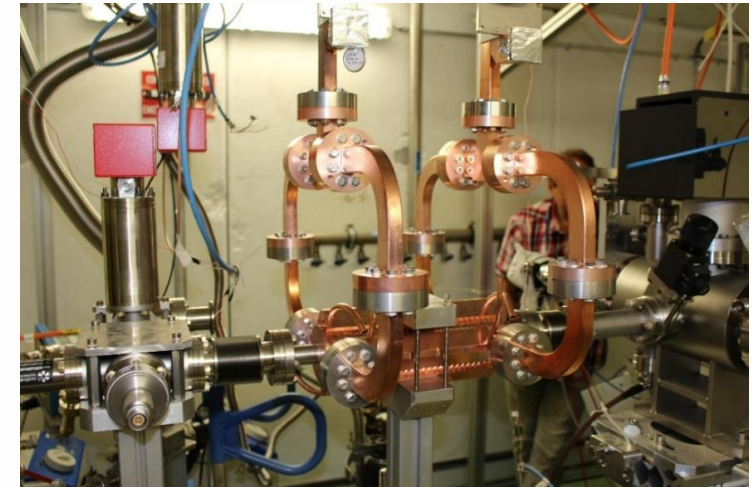
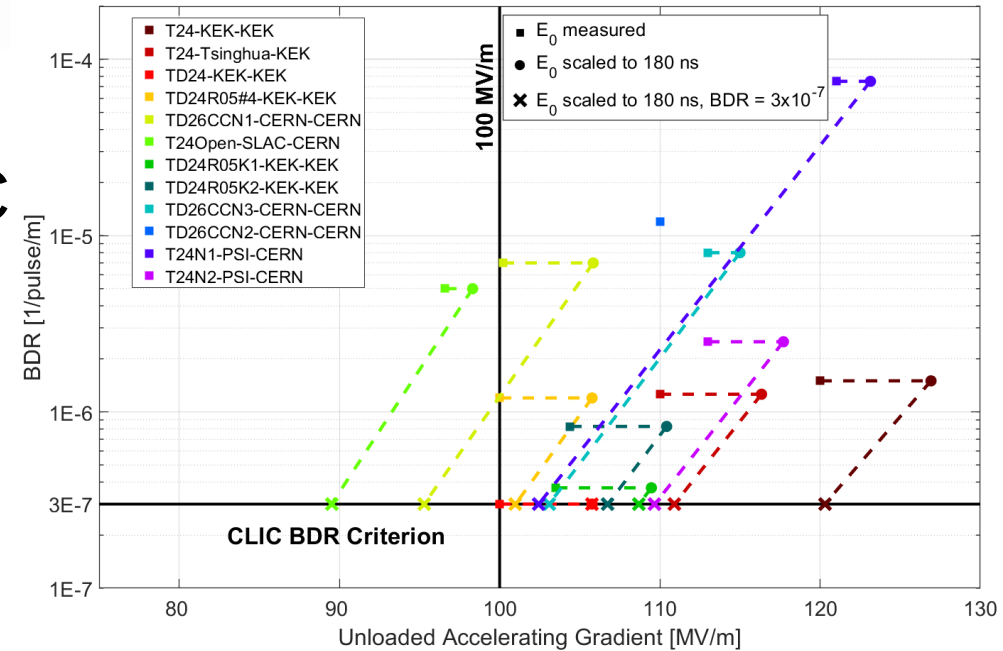




X-band high-gradient accelerating structure as main linac

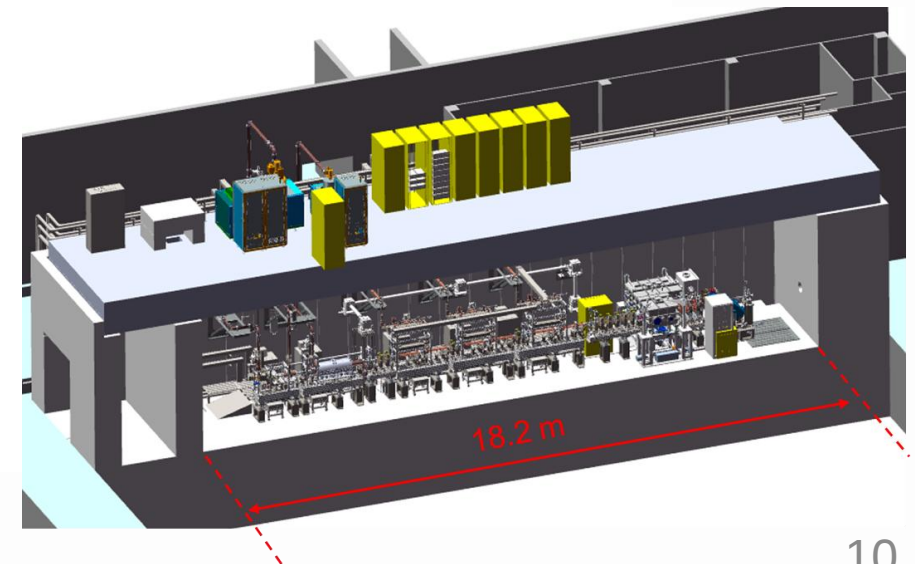
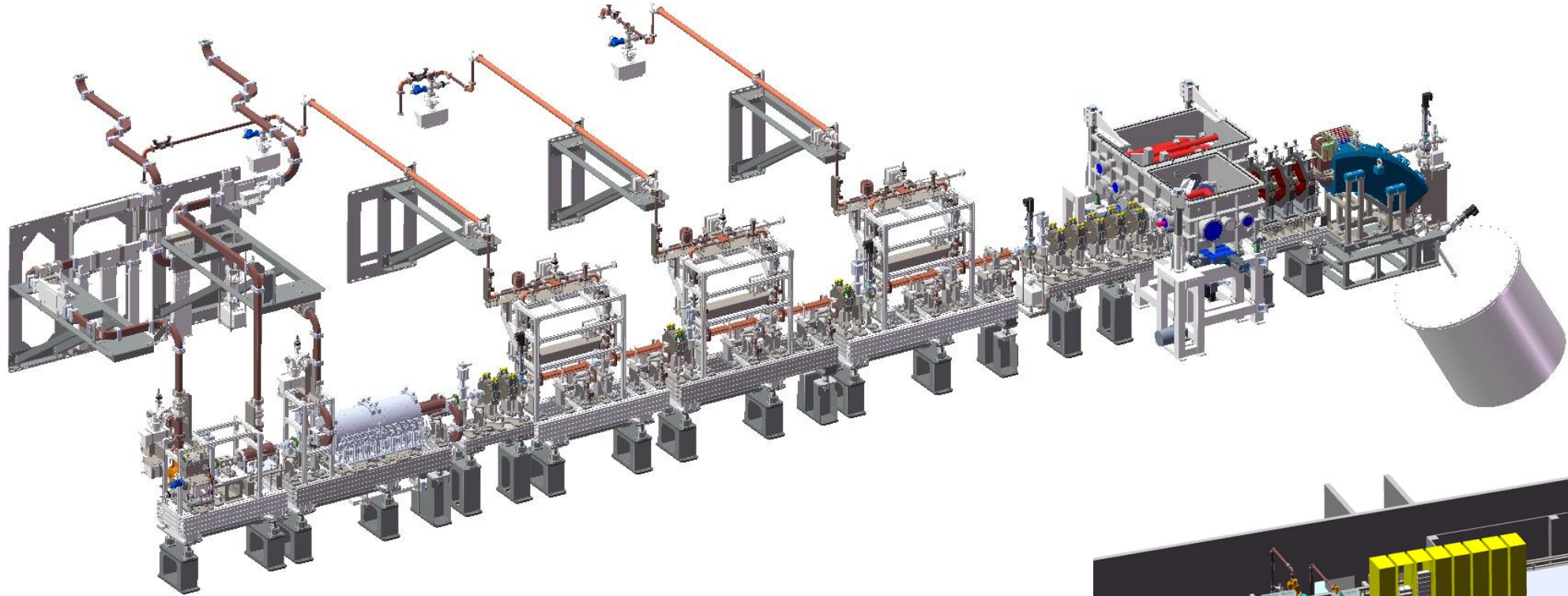
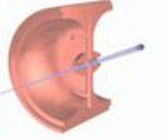
- X-band Normal Conducting technology was proposed for linear collider NLC/JLC CLIC ...
- $> 100\text{MV/m}$ demonstrated globally
- $\sim\text{km}$ facility
- requires very low breakdown rate
- 80MV/m 62.5cm @ 11.424GHz chosen as the main linac design for our **12m-long 350MeV very compact facility**

<https://doi.org/10.1103/PhysRevAccelBeams.21.061001>,
<https://doi.org/10.1103/PhysRevAccelBeams.20.052001>



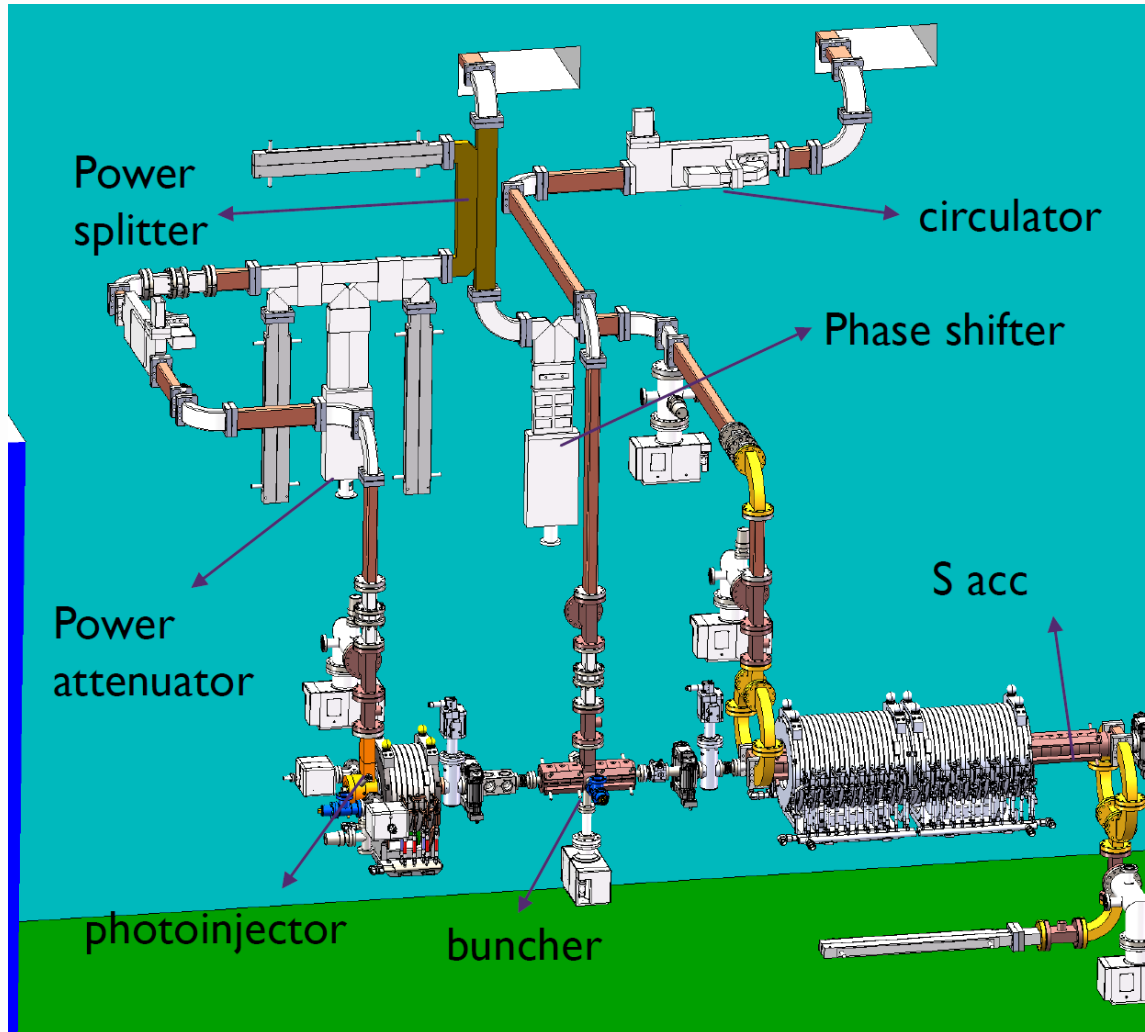


Overview of Accelerator System





S-band waveguide system

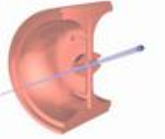


- 50 MW power from Canon E3730A feeds for photoinjector and S acc
 - 5dB power splitter
 - Phase shifter for S acc phase control
- 7.5 MW power from Canon E3772 feeds for buncher
- Consider RF loss due to waveguides and components

	Transmitted power (MW)	Needed power (MW)
Photoinjector	11.7	7
S acc	29	21
buncher	6.4	3



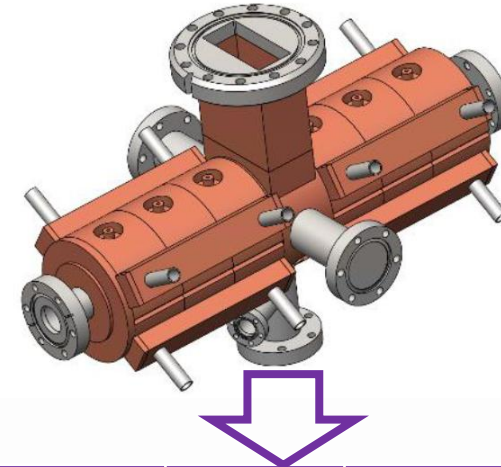
S-band injector & buncher



Zheng, Lianmin, et al.
NIMA 834 (2016): 98-107.

Parameters	Value	Unit
π mode frequency	2856	MHz
Q_0	14000	
Working field strength	100-120	MV/m
Emitting charge	>200	pC
Cathode material	Copper	
Quantum efficiency	$3.5-4 \times 10^{-5}$	
Emittance	~ 0.6	μm

Parameters of S-band injector



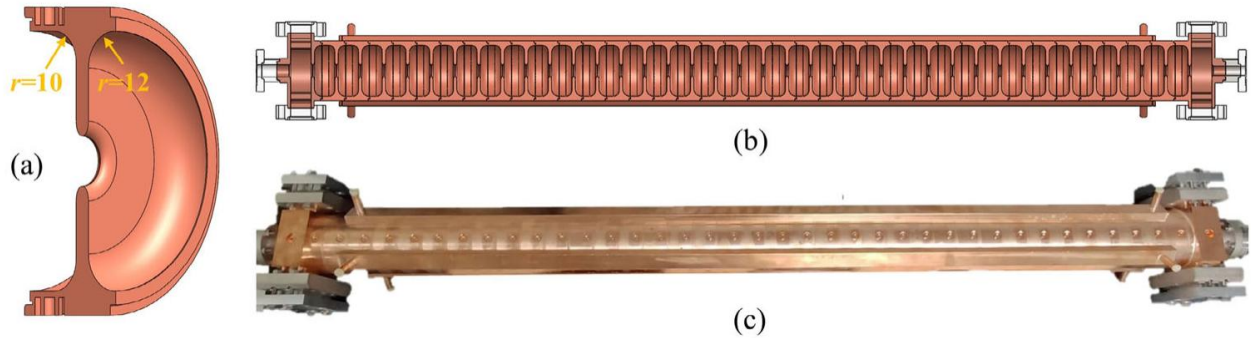
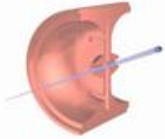
Parameters	Value	Unit
π mode frequency	2856	MHz
Q_0	17000	
Coupling coefficient	1.2	
Shunt impedance	50	$\text{M}\Omega/\text{m}$
Working field strength	23	MV/m

Parameters of S-band 7-cell buncher

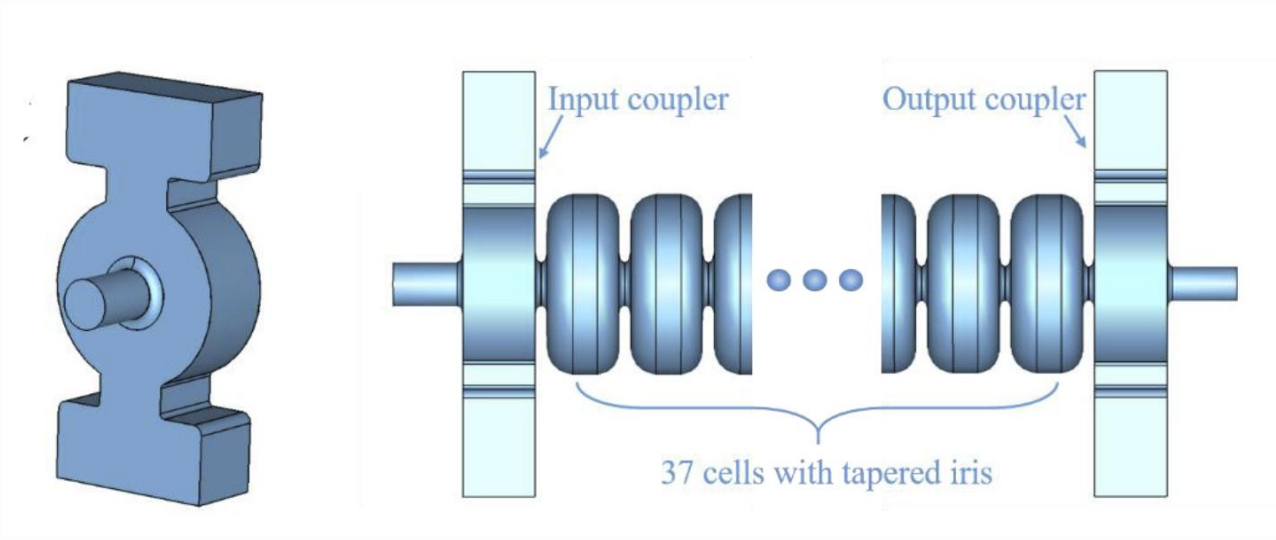




S-band TW acc

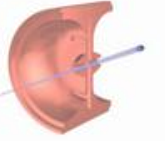


Design Parameters	Value	Unit
Frequency	2856	MHz
Phase advance	$3\pi/4$	
Length	1.535	m
Cell number	39	
Iris radius	10.22-8.13	mm
Iris thickness	5.7	mm
Iris elliptical ratio	1.8	
Filling time	1050	ns
Group velocity	0.72-0.30	%/c
Shunt Impedance	66-72	MΩ/m
Average Gradient	25.7@21MW	MV/m



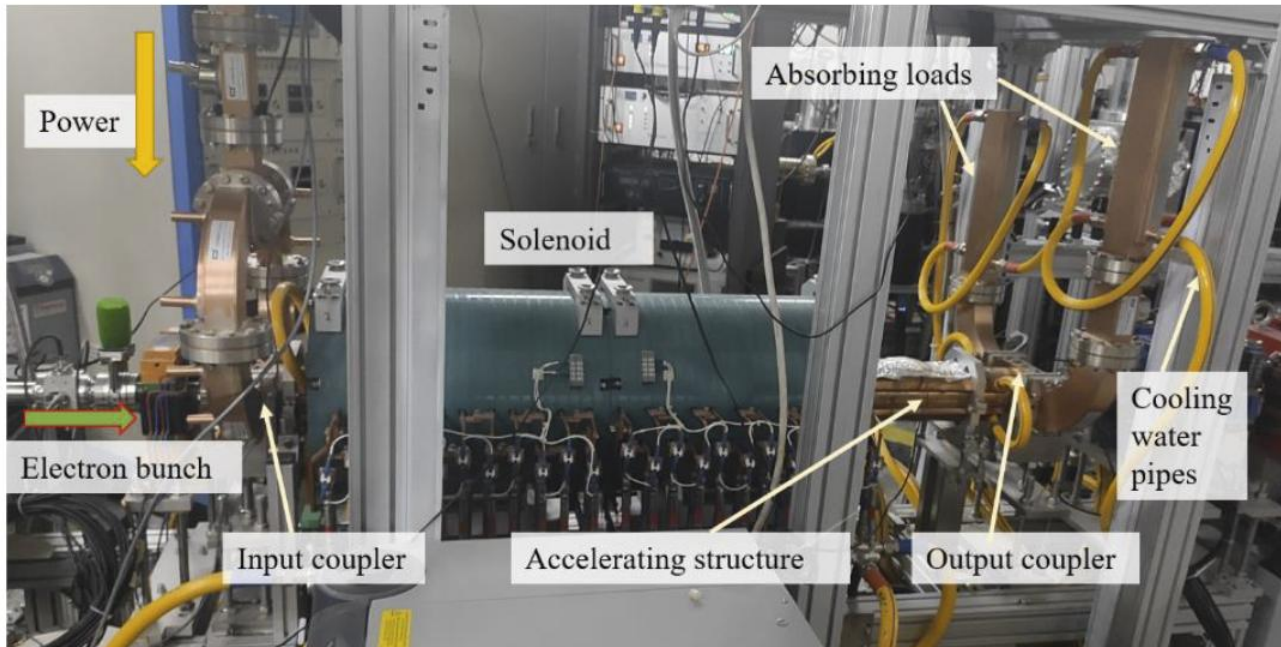
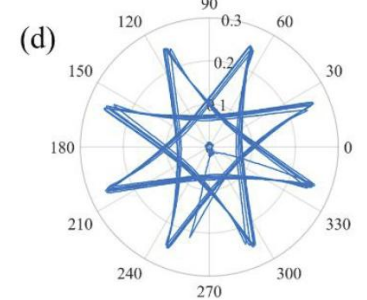
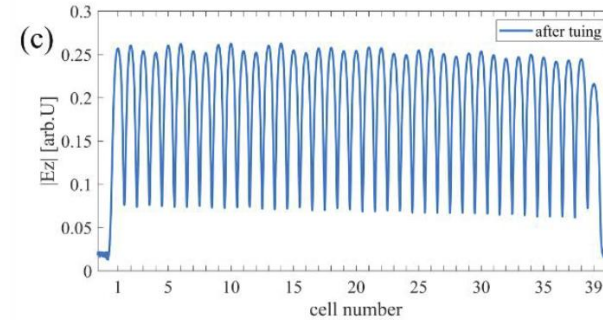
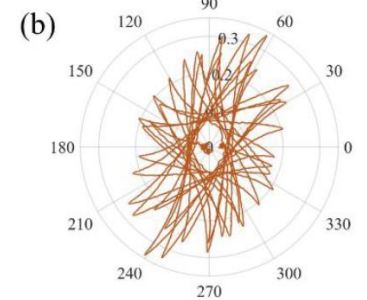
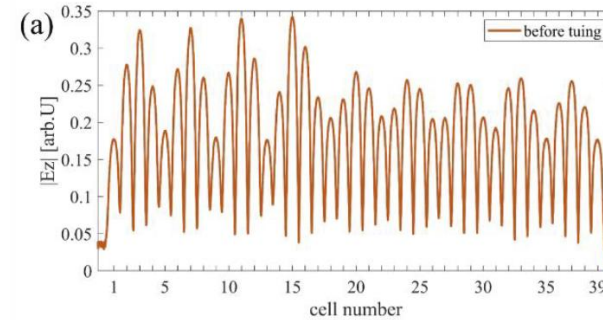
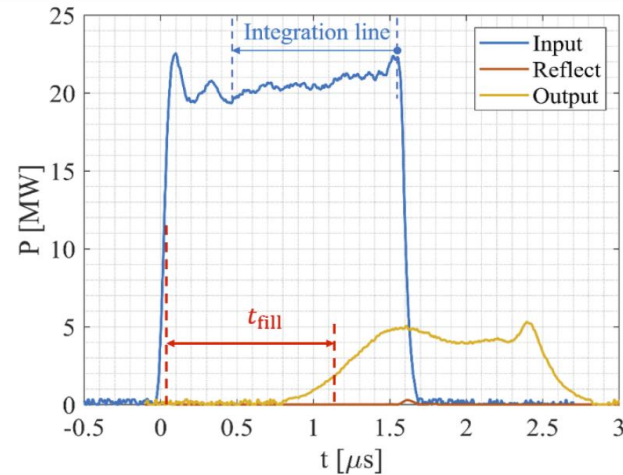


S-band TW acc



High power tested

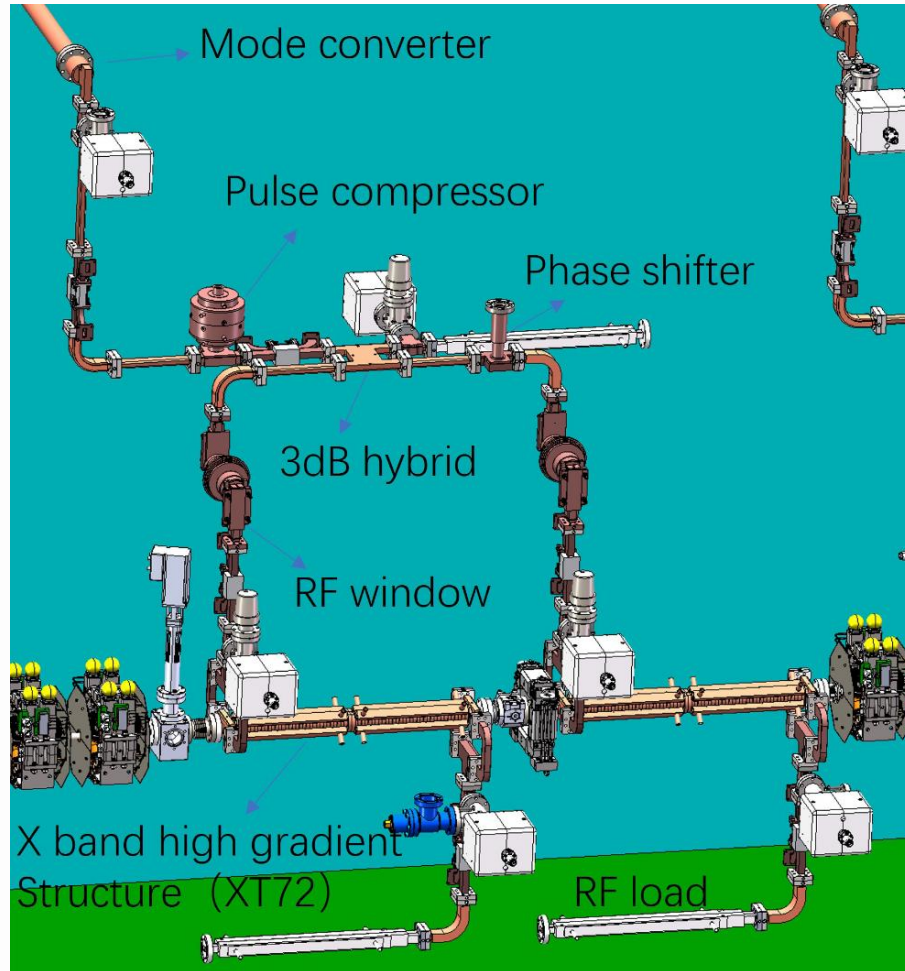
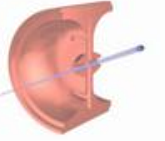
- Conditioning:
 - 120 hours
 - 4 million pulses



Parameters	Measurement	Simulation
Frequency	2.856 GHz	2.856 GHz
Phase advance	134.97°	135°
Gradient @20.7MW	24.2 MV/m	25.7 MV/m
Filling time	1090 ns	1050 ns



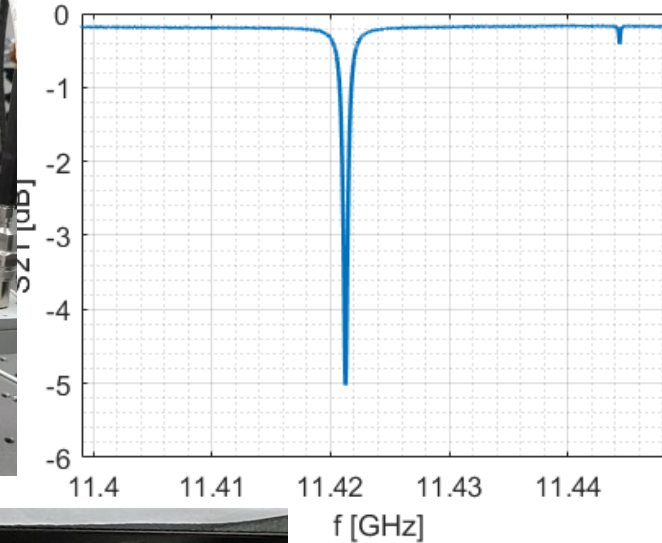
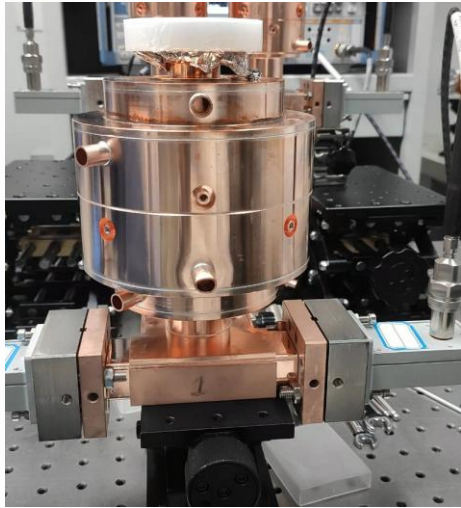
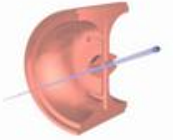
X-band waveguide system



- One klystron
 - 50MW, 1.5 μ s
- One pulse compressor (SLED I type)
- Maximum rf loss due to waveguides and rf components from klystron to Xacc is about 0.9dB
- Peak power at Xacc input is about 91 MW if power compressor gives gain factor as 4.5
- Two X band high gradient structures
 - Average gradient ≥ 80 MV/m
 - Energy gain per structure > 50 MeV
 - Filling time < 150 ns

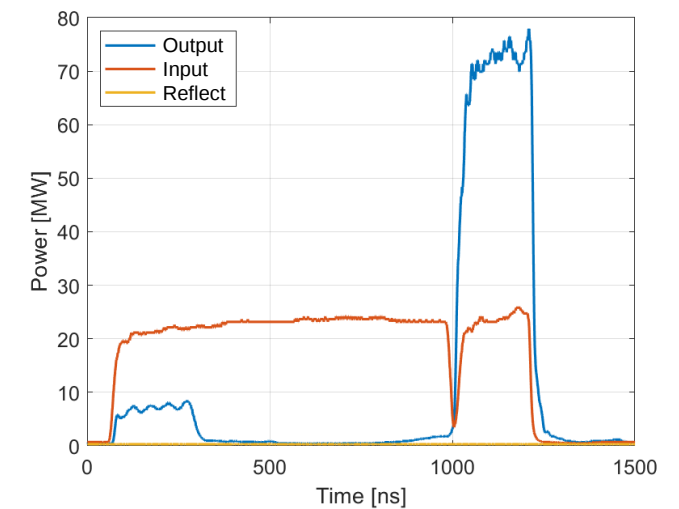
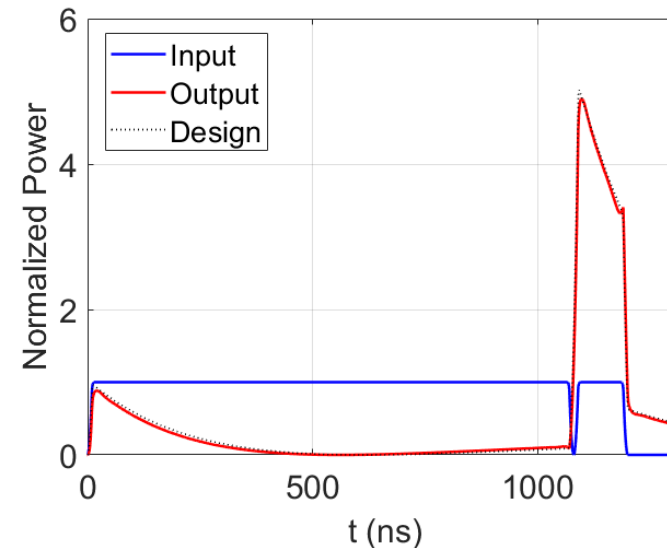
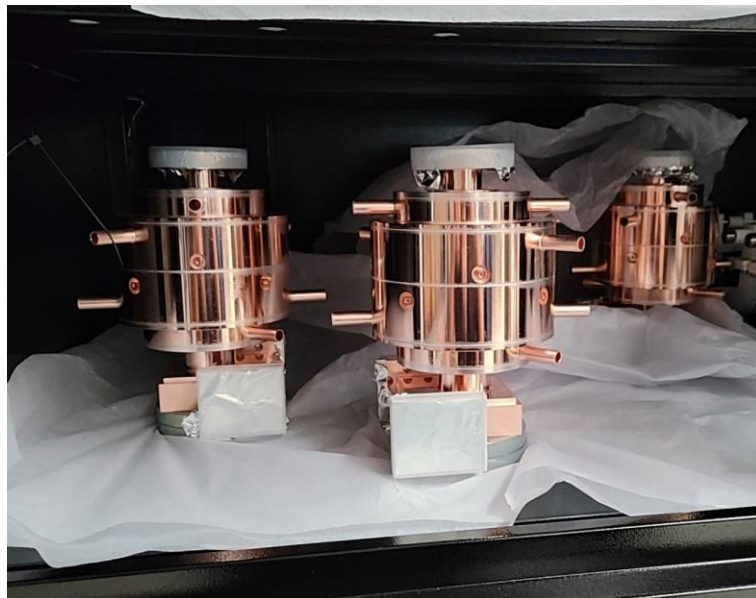


X-band pulse compressor



	f	Q_0	Q_e	β
Design	11.4240	9.2e4	2.63e4	3.5
Measure	11.4213	9.19e4	2.51e4	3.66
Mode 1	11.4213	9.25e4	2.52e4	3.67
Mode 2	11.4213	9.05e4	2.46e4	3.68

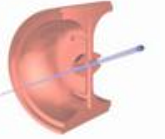
*Modes 1 and 2 are parameters of two polarization modes reconstructed from measured S-parameters (TE_{114})



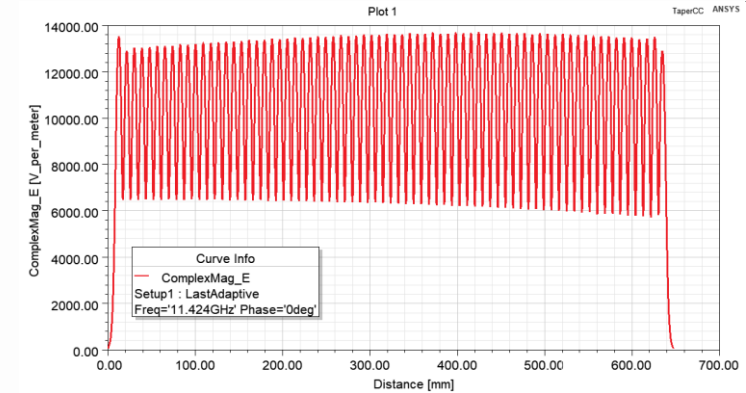
*Franzi, Matthew, et al. *PRAB*19.6 (2016): 062002.



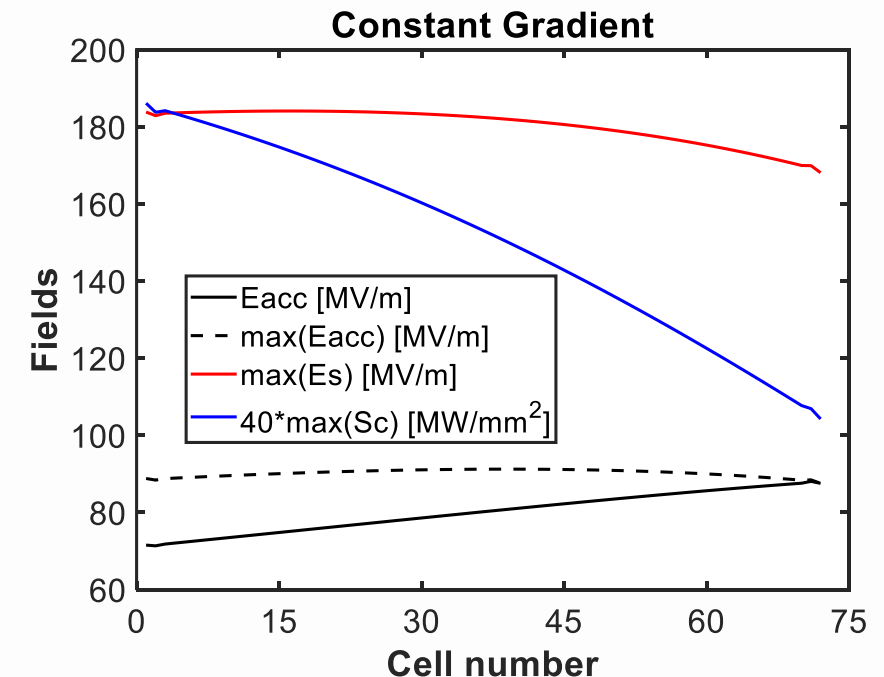
X-band TW linac



- We switch to CG scheme with maximum surface field 20% lower than CI

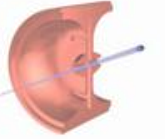


Parameters	CI	CG
Iris aperture a [mm]	3.5	3.92 ~ 3.12
Iris thickness d [mm]	1.8	1.8
Shunt imp. R [MΩ/m]	101	93 ~ 109
Group velocity v_g/c	2.20%	3.22% ~ 1.46%
Quality factor Q	6990	7020 ~ 6970
Filling time T_f [ns]	95	97
E_s [MV/m]	224	185
S_c [MW/mm ²]	5.65	4.50
β of pulse compressor	3.5	3.5
Pin @80MV/m with pc [MW]	81.3	80.1

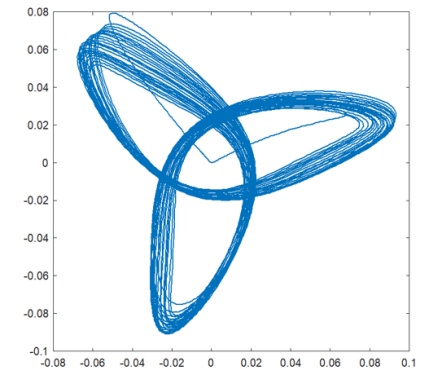
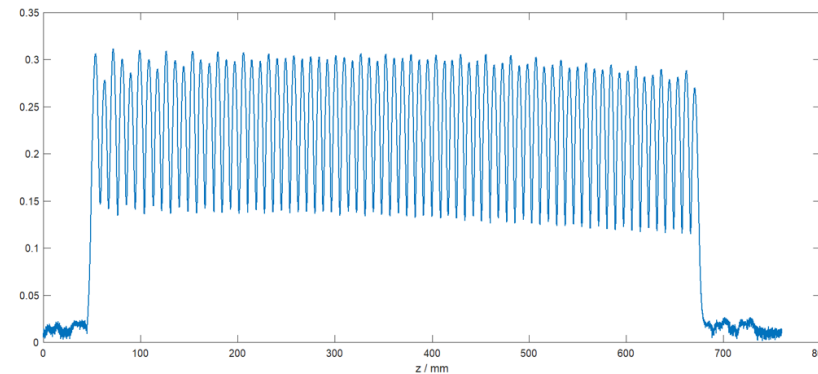
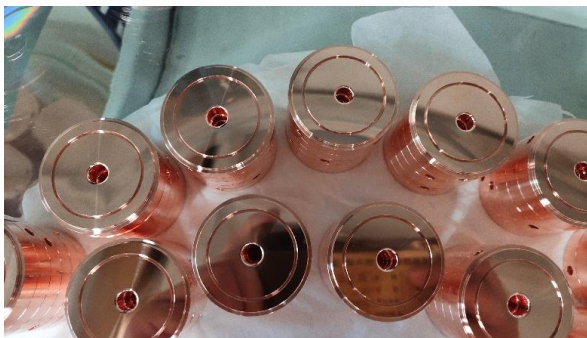
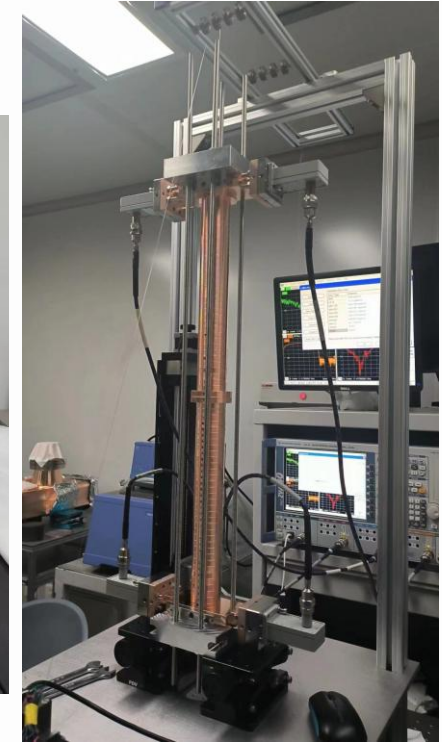
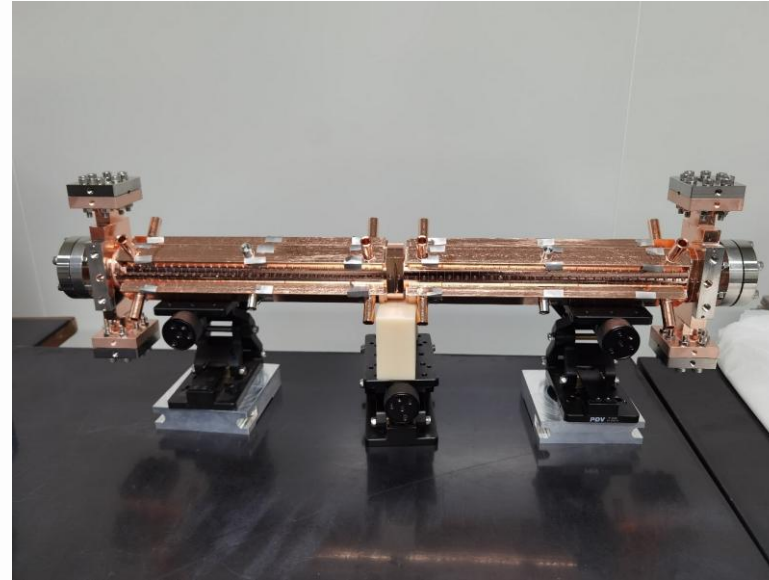




X-band TW linac

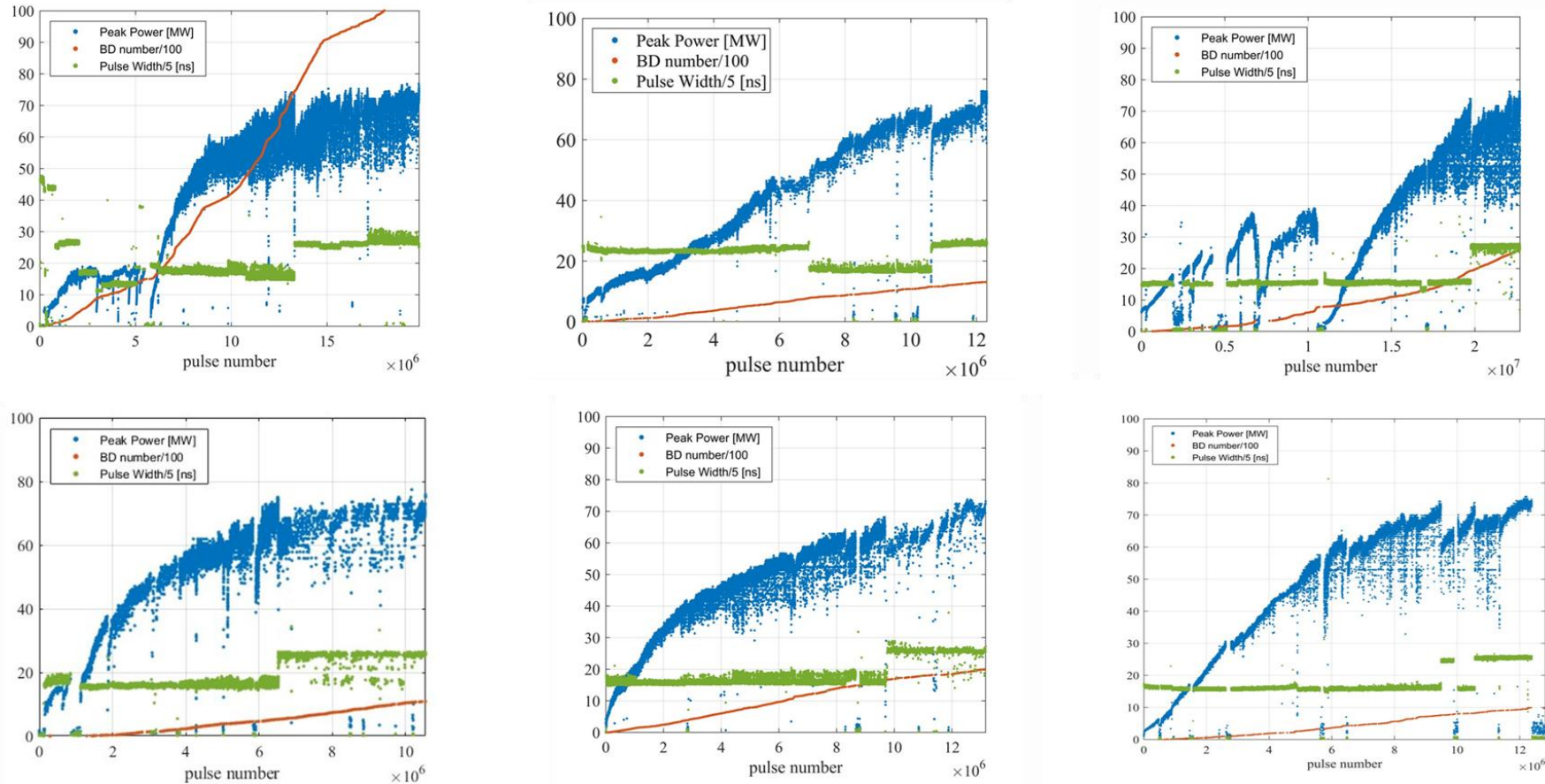


- XT72 (X-band Tapered structure with 72 cells)
- COST: CG 20% higher than CI
- Same Tuning procedure
- High power conditioning started from Oct. 20, 2023





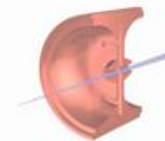
High-gradient performance of xt72



- All 6 accelerating structures were conditioned
- To reach 80MV/m, ~15 million pulses, About **100 hours of conditioning at 40Hz**



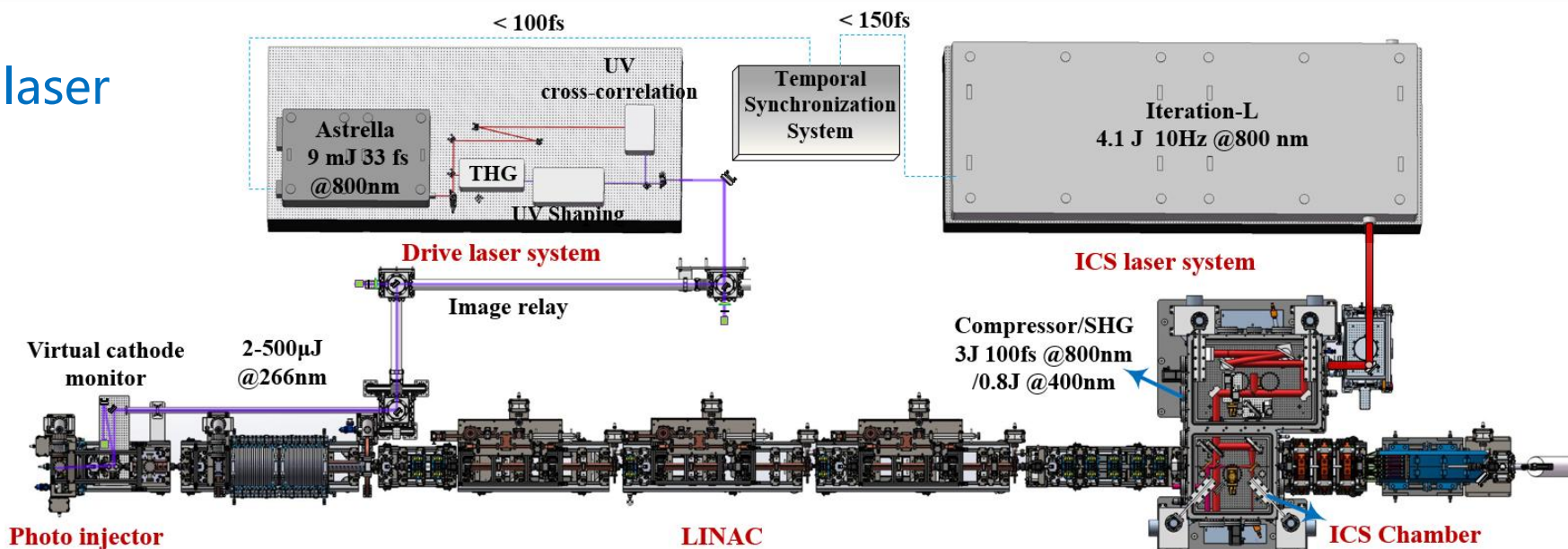
Laser system of VIGAS



➤ The Laser system layout of the VIGAS facility Schematic

- Photo-injector driving laser
- Inverse Compton Scattering laser

➤ Parameters of the laser system



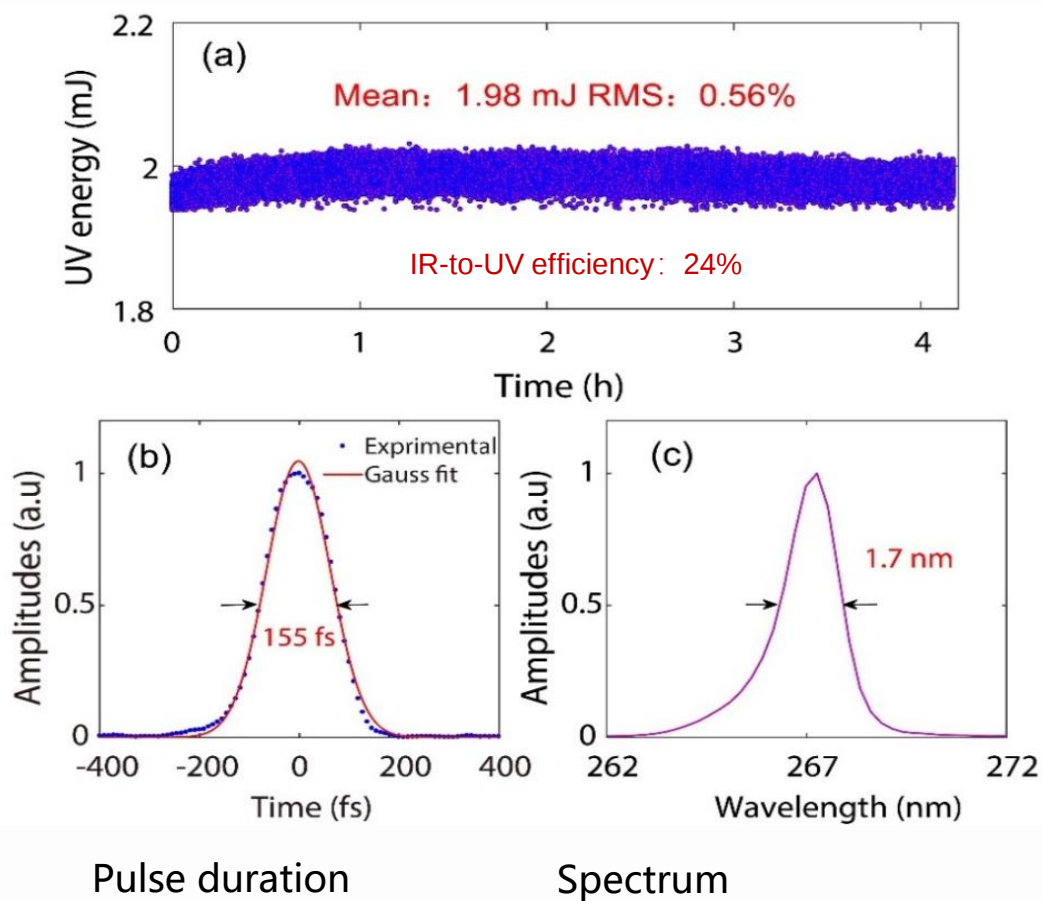
	Central wavelength	Pulse width (FWHM)	Pulse energy	rate	Beam size (RMS)	Temporal distribution	Spatial distribution	Energy jitter (RMS)	Laser- RF jitter (rms)
Driving laser	~267 nm	5~10 ps	2~500 μ J	10 Hz	0.2~2 mm	Quasi-flat top	Quasi-flat top	< 2%	< 100 fs
ICS laser	800 nm /400 nm	0.1~10 ps	>1.5 J@800 nm / >0.8 J@400 nm	10 Hz	< 10 μ m	Gaussian	Gaussian	< 1.2 %	< 150 fs

[illegible]

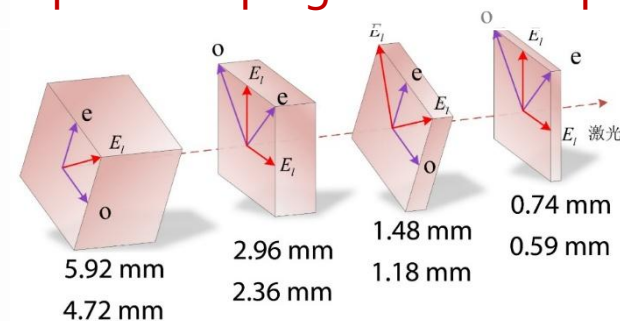
Experimental results

- Output of THG

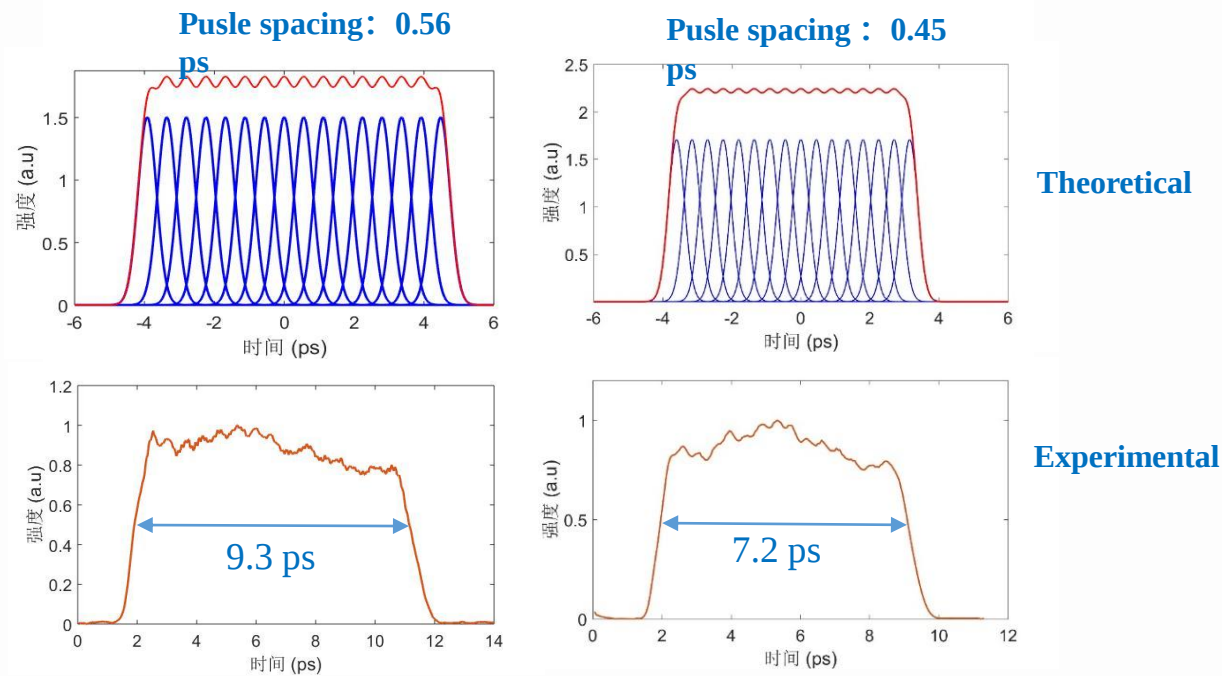
The UV laser pulse energy and stability



- Temporal shaping of UV laser pulse



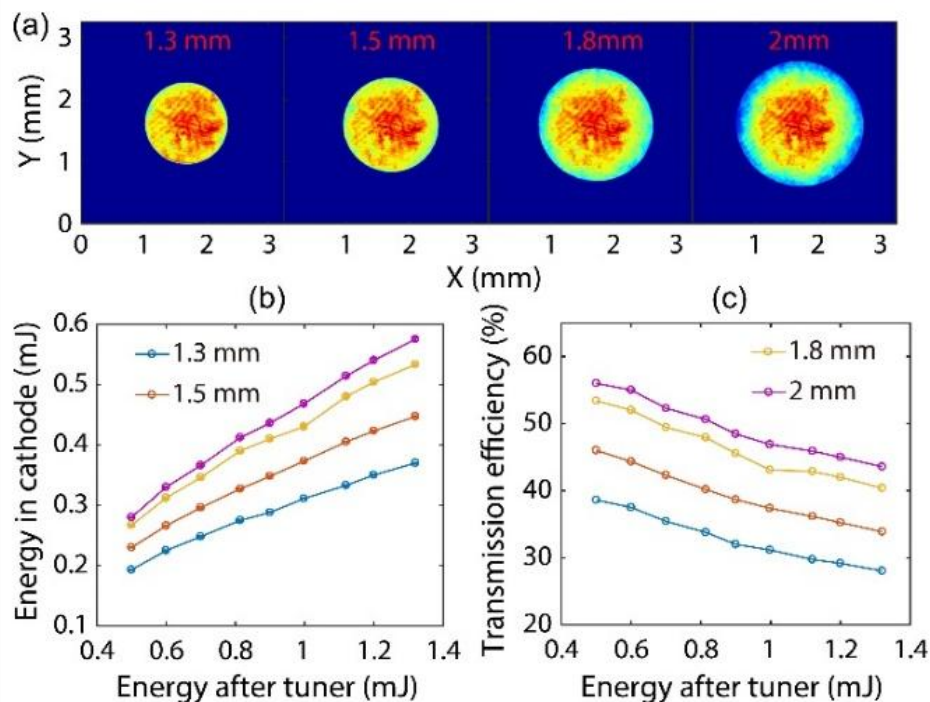
Pulse stacking of α -BBO crystals



Experimental results

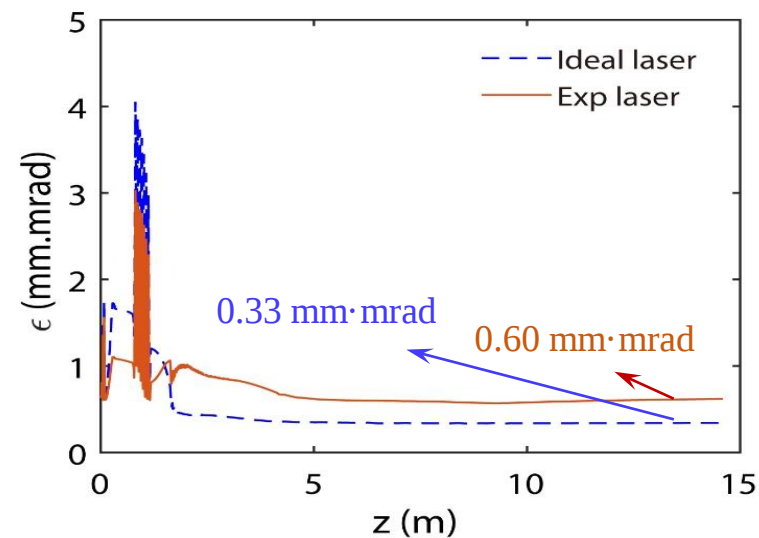
- Spatial shaping of UV laser pulse

The UV laser beam size (1.3mm, 1.5mm, 1.8mm, 2mm) spatial distribution, pulse energy and transmission efficiency in the photo-cathode, the maximum pulse energy is 0.58 mJ, the maximum transmission efficiency is 56%.



- Simulation of the beam normalized rms emittance

The beam normalized rms emittance simulated by GPT code based on the ideal flat-top distribution (blue dashed line) and the experimental results (orange solid line) of the driving laser.



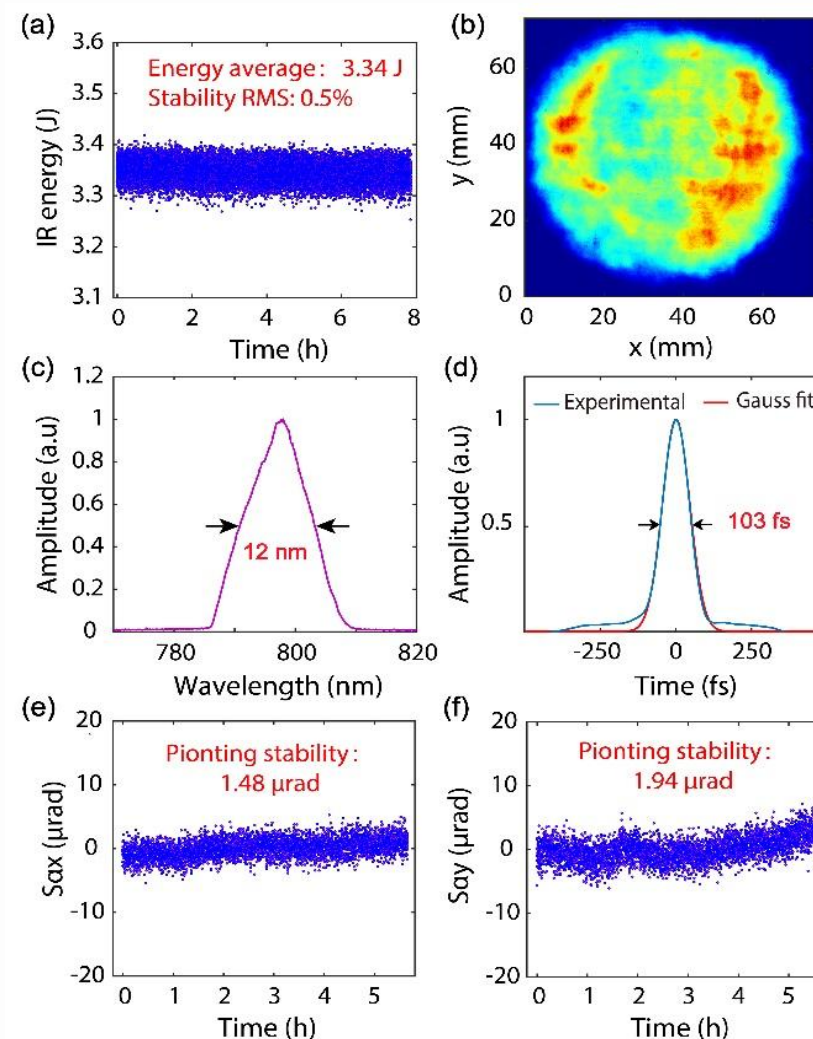
$z=14$ m, $Q=200$ pC
 $\epsilon_{\text{ideal}} = 0.33$ mm.mrad, $\epsilon_{\text{Exp}} = 0.60$ mm.mrad

ICS laser



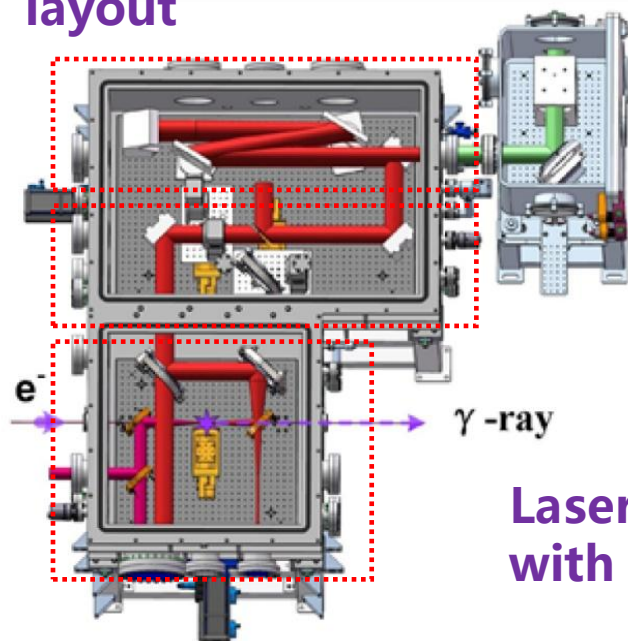
The 30 TW Ti:sapphire laser device was completed in April 2025.

30 TW Ti: spphire	Measurements
Central wavelength	798.14 nm
Spectrum (FWHM)	12 nm
Pulse energy	3.28 J
Pulse width (FWHM)	103 fs
Energy stability (RMS)	0.52% (16hrs)
Point stability (RMS)	X: 1.48 μ rad ; Y:1.94 μ rad
Laser-RF jitter (rms)	< 80 fs



ICS laser transmission and modulation

➤ Optical layout



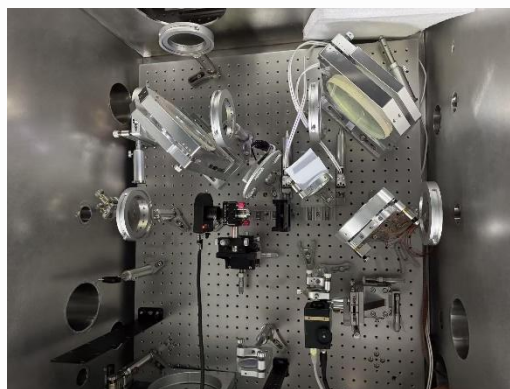
Pulse compressor

Second harmonic generation
and polarization adjuster

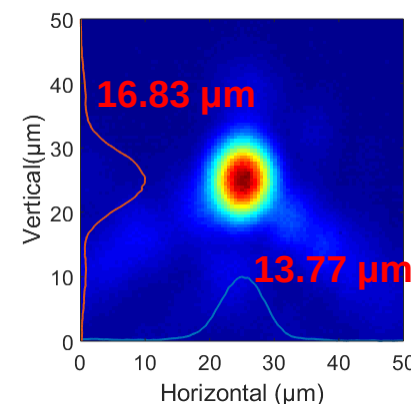
Laser focus and scattering
with electron beam



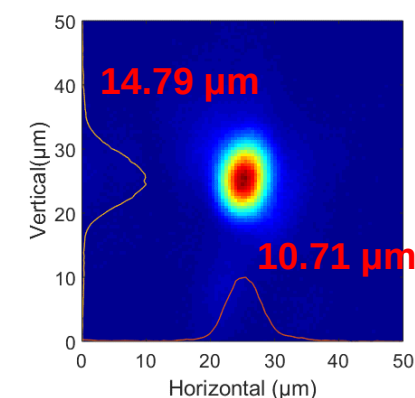
➤ Setup in vacuum chamber



Laser focus profile



Wavefront
correction



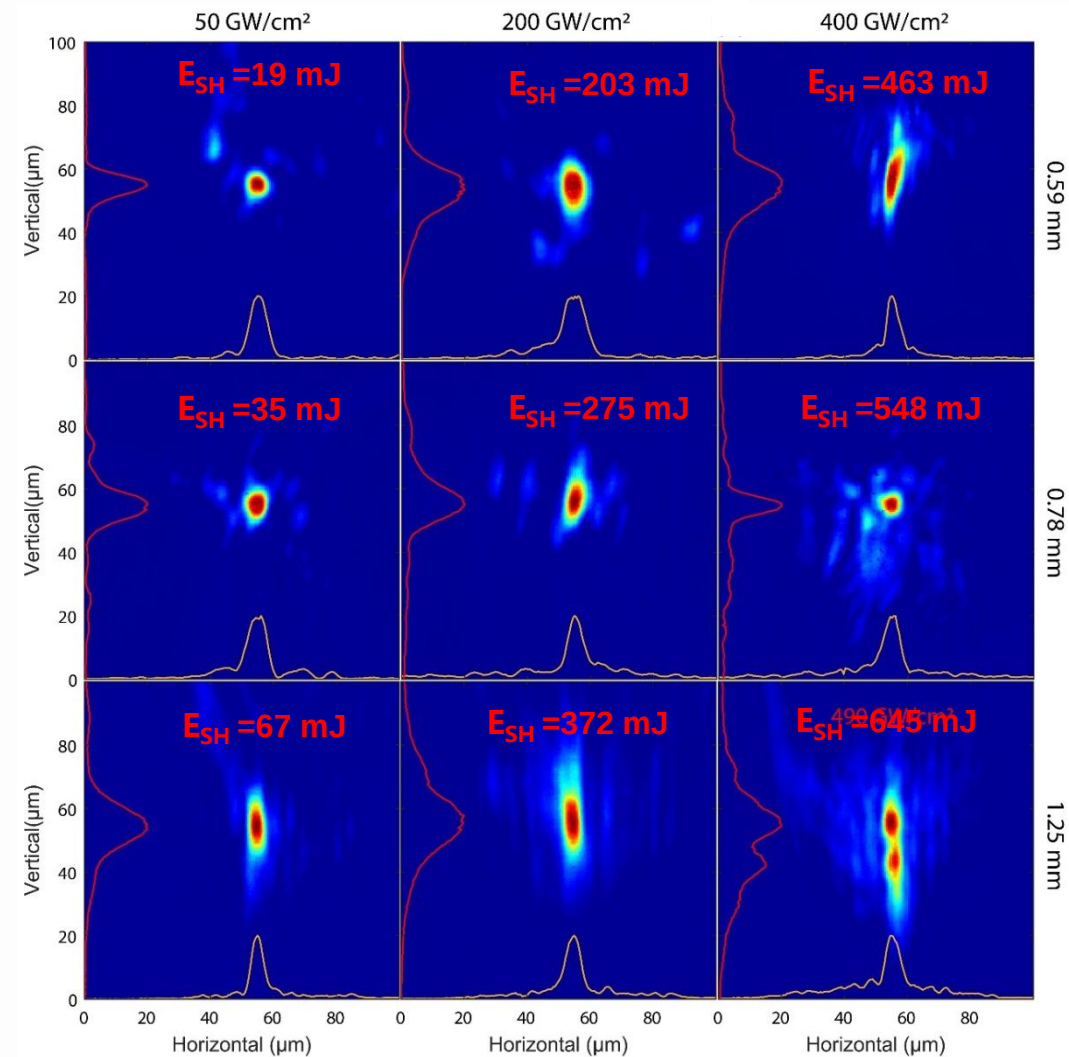
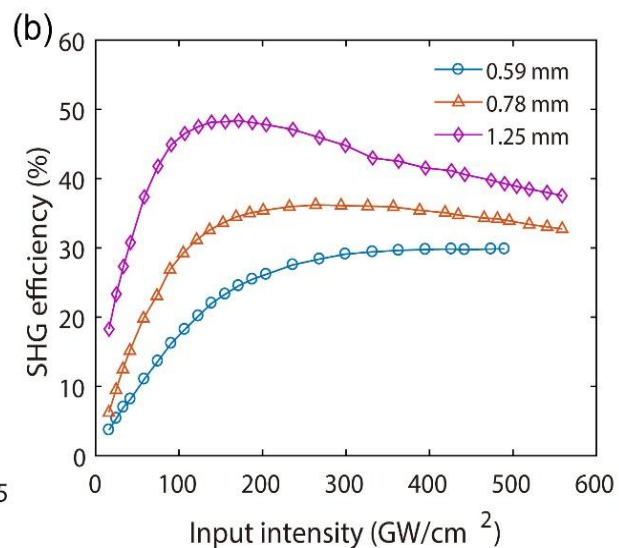
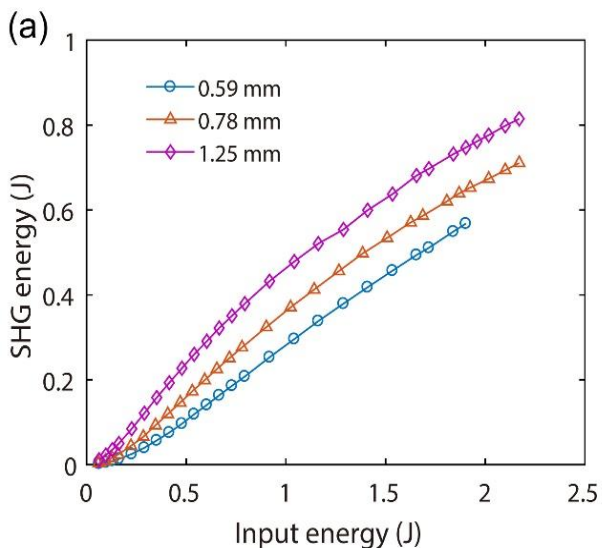
SHG and Focusing Characteristics of High-Energy Lasers

Generate higher-energy gamma rays ($> 1 \times 10^8$ photons $\cdot$ s $^{-1}$ @2.4~4.8 MeV) by increasing the photon energy of the scattering laser (800 nm $\rightarrow$ 400 nm, $E_{SH} > 0.8$ J).

- Crystal parameters

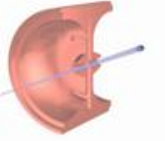
KDP , Type- I at 800 nm: $\theta=44.9^\circ$, $\Phi=45^\circ$

	1	2	3
thickness/ mm	0.59	0.78	1.25
Size/mm	75	85	85





Progress and summary

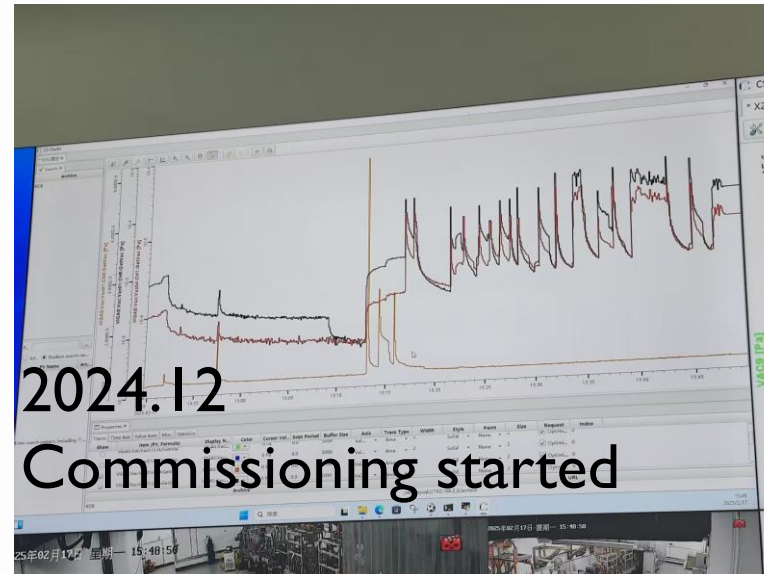


2023.9

2024.06
Bunk ready

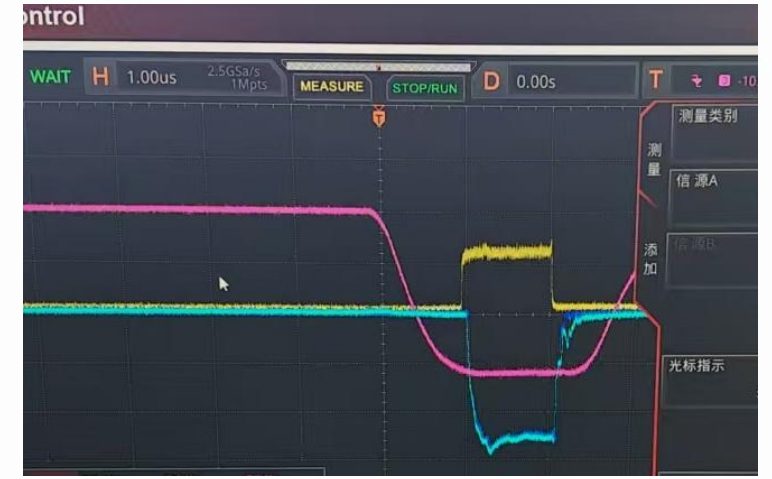
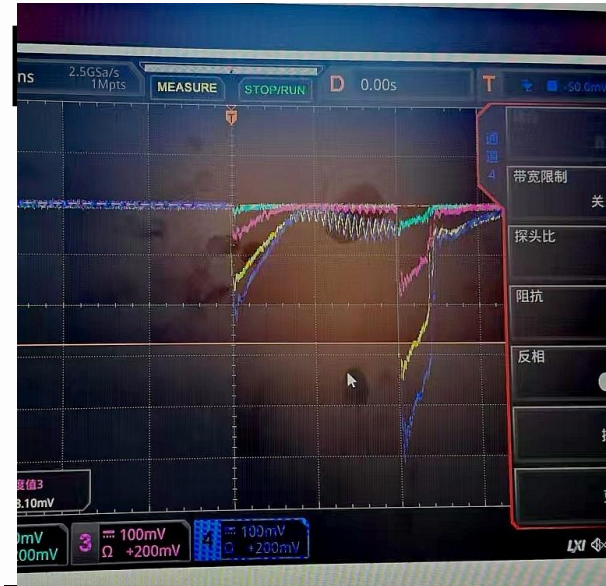


2024.11 finish installing





- Commissioning of RF power source was started from the end of 2024
- Conditioning of the S-band and X-band RF modules was started in the first quarter of 2025
- Beam has been detected on the YAG screen in March



Signal of RF power



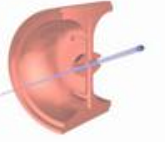
Beam on YAG sceen



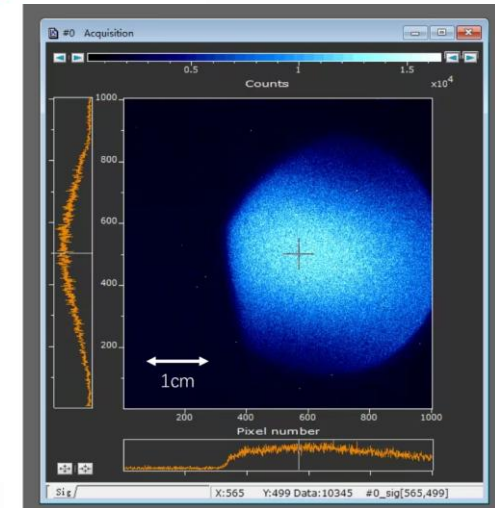
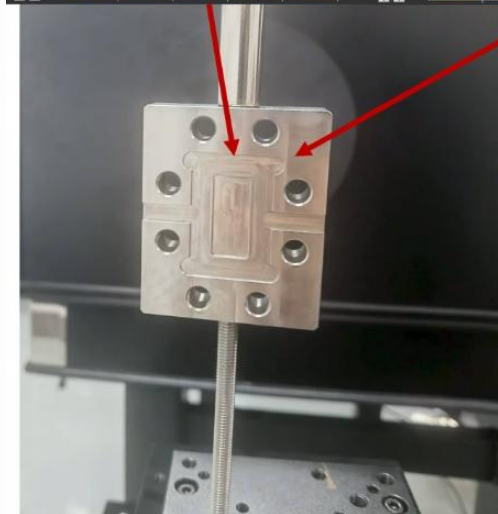
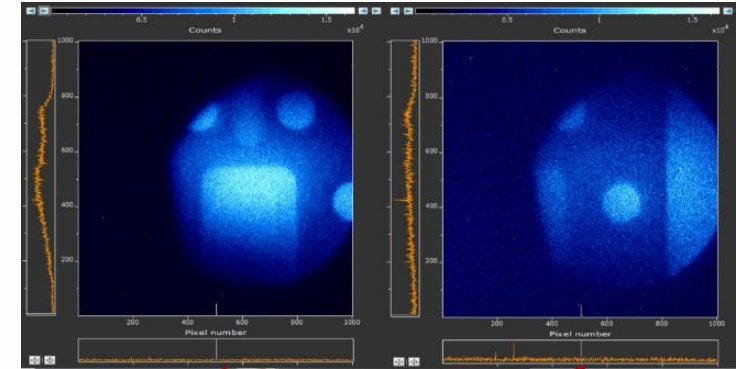
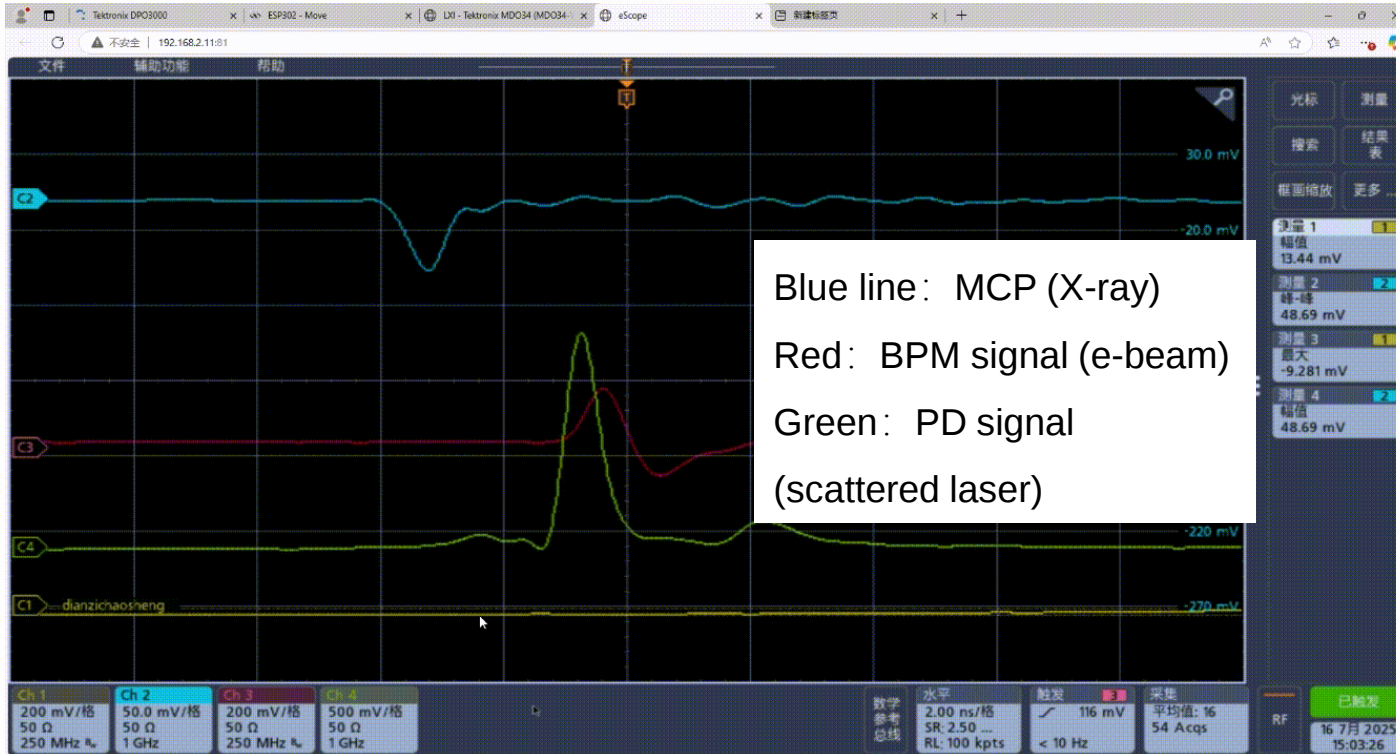
Beam passing through bending magnet



Progress and summary



Successful generation of high-energy X-rays in collision experiment in mid-2025



During the adjustment of the relative delay between the e-beam and the scattered laser, the X-ray signal detected by the MCP

The X-ray ($\sim 500\text{keV}$) spot 9 m from the interaction point



Thank you for your attention!

